

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of :  
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Sun Jin YUN et al. : Confirmation No. 4540  
:   
U.S. Patent Application No. 10/777,102 : Group Art Unit: 2815  
:   
Filed: February 13, 2004 : Examiner: DIAZ, JOSE R

For: SUBSTRATE WITH MICROSTRUCTURE FORMED THEREON AND  
MANUFACTURING METHOD THEREOF

**SUPPLEMENTAL AMENDMENT**

**MAIL STOP AMENDMENT**  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria VA 22313-1450

Sir:

In response to the Office Action of December 24, 2008, please amend the above-identified application and enter the following remarks, as follows:

- **Amendments to the Claims** as reflected in the listing of claims; and
- **Remarks.**